

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Tois et al.
App. No	: 10/678,766
Filed	: October 2, 2003
For	: METHOD OF GROWING OXIDE THIN FILMS
Examiner	: Matthew J. Song
Art Unit	: 1792
Conf #	: 1629

RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Office Action that was mailed on January 24, 2008 and is accompanied by a request for a three-month extension of time. Applicants respectfully request consideration of the following remarks.

Listing of the Claims begins on page 2 of this paper.

Summary of Interview begins on page 6 of this paper.

Remarks/Arguments begin on page 7 of this paper.